12-04-2002

Atty Docket No.:

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RECORDATION FORM COVER SHEET





U.S. DEPARTMENT OF COMMERCE Patent and Trademark Office

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Vaidyanathan BALASUBRAMANIAM, Masaaki HAGIWARA, Eiichi NISHIMURA and Kouichiro INAZAWA	Name: TOKYO ELECTRON LIMITED Address: TBS Broadcast Center
Additional name(s) of conveying party(ies) attached? ☐ Yes ■ No	3-6, Akasaka 5-chome, Minato-ku, Tokyo 107-8481, JAPAN
3. Nature of Conveyance:	
Assignment	
☐ Security Agreement ☐ Change of Name	
☐ Other	
Execution Date: October 9, 23, 18, 15, 2002	Additional name(s) and address(es) attached? □Yes
4. Application number(s) or patent number(s):	
If this document is being filed together with a new application, the ex	ecution date of the application is:
A. Patent Application No.(s)	B. Patent No.(s)
10/259,768	
Additional numbers attached	.d? □ Yes ■ No
5. Name and address of party to whom correspondence concerning document should be mailed:	6. Total applications and patents involved: 1
concenning document should be maned.	
I BARKA MATA HALI KOMA BOIK ARK TAKI	7. Total fee (37 CFR 3.41): \$40.00 Enclosed
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22850	8. Deposit account number: 15-0030 (Attach duplicate copy of this page if paying by deposit account)
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To the best of my knowledge and belief, the foregoing information copy of the original document.	\mathcal{O}
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2002 GTON11 00000096 10259768 Commissioner of Patents	
Box Assigns	

WHEREAS, I (WE) Vaidyanathan BALASUBRAMANIAM, 101 Ra	ntoul	
Street, Apt. 108, Beverly, MA 01915; Masaaki HAGIWARA, 7 E		
Commons Drive, Apt. 37, Beverly, MA 01915; Eiichi NISHIMUF	RA, 192	
Kennedy Drive, Apt. 710, Malden, MA 01248; Kouichiro INAZA	WA,	
Nakatamachi Nakajo 1888 B302, Nirasakishi Yamanashi 407-0	626	
JAPAN		

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		hav
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METHOD FOR REMOVING PHOTORESIST AND ETCH RESIDUES		
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WHEREAS, Tokyo Electron Limited		
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NOW, THEREFORE, in consideration of the sum of FIVE DOLLARS (\$5.00), the receipt whereof is hereby acknowledged, and for other good and valuable consideration, I (WE), by these presents do sell, assign and transfer unto said ASSIGNEE, the full and exclusive right to the said invention in the United States and its territorial possessions and in all foreign countries and the entire right, title and interest in and to any and all Letters Patent which may be granted therefor in the United States and its territorial possessions and in any and all foreign countries and in and to any and all divisions, reissues, continuations, substitutions and renewals thereof.

I (WE) hereby authorized and request the Patent Office Officials in the United States and its territorial possessions and any and all foreign countries to issue any and all of said Letters Patent, when granted, to said ASSIGNEE as the assignee of my (our) entire right, title and interest in and to the same, for the sole use and behoof of said ASSIGNEE, its (his) successors and assigns, to the full end of the term for which said Letters Patent may be granted, as fully and entirely as the same would have been held by me (us) had this Assignment and sale not been made.

The undersigned hereby grant(s) the firm of Oblon, Spivak, McClelland, Maier & Neustadt, P.C. of Fourth Floor, 1755 Jefferson Davis Highway, Arlington, Virginia 22202 the power to insert on this assignment any further identification, including the application number and filing date, which may be necessary or desirable in order to comply with the rules of the United States Patent and Trademark Office for recordation of this document.

Date: 10/09/2002	Vaid	100 alli	
	(Signature of Inventor)	nathan BALASUBRAMANIAN	V
Date:	(Signature of Inventor)	Masaaki HAGIWARA	
Date:			
	(Signature of Inventor)	Eiichi NISHIMURA	
Date:	(Signature of Inventor)		
	(Signature of inventor)	Kouichiro INAZAWA	
Date:	(Signature of Inventor)		
Date:			
	(Signature of Inventor)		
Date:	(G:		
	(Signature of Inventor)		
Date:	(Signature of Inventor)		

OBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, P.C.
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ARLINGTON, VIRGINIA 22202

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Date: 10/23/02	(Signature of Inventor) Masaaki HAGIWARA
	(Signature of Inventor) Masaaki MAGIWARA
Date:	
	(Signature of Inventor) Eiichi NISHIMURA
Date:	
	(Signature of Inventor) Kouichiro INAZAWA
Date:	
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	(Signature of Inventor)

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	(Signature of Walloyanathan BALASUBRAMANIAM
Date:	
	(Signature of Inventor) Masaaki HAGIWARA
Date: OCt. 18. 2002	
	(Signature of Inventor) Eilchi NISHIMURA
Date:	
	(Signature of Inventor) Kouichiro INAZAWA
Date:	
	(Signature of Inventor)
Date:	
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Date:	(Signature of Inventor) Masaaki HAGIWARA
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Date:	(Signature of Inventor) Eiichi NISHIMURA
Date: Oct, 15, 2002	Korichiro Lagana
	(Signature of Inventor) Kouichiro INAZAWA
Date:	(Signature of Inventor)
Date	,
Date:	(Signature of Inventor)
Date:	
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PATENT RECORDED: 11/26/2002 REEL: 013550 FRAME: 0979